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New Approach to Pull-In Limit and Position Control of Electrostatic Cantilever Within the Pull-In Limit

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1. Introduction

Since electrostatic cantilevers are very easy to fabricate, have small dimension, and consume low power, they have been very popular as a sensor. They had been used as a capacitive pressure sensor for measuring blood pressure (Hin-Leung Chau & Wise, 1988), as a microwave switch (Dooyoung Hah et al., 2000), as an air flow sensor (Yu-Hsiang Wang et al., 2007), as a micro-actuator for probe-based data storage (Lu & Fedder, 2004), and in well known commercial applications like inkjet head (Kamusuki et al., 2000), and optical scanners (Schenk et al., 2000).

An electrostatic MEMS cantilever is a simple capacitor consists of two parallel conductive plates. The bottom conductive plate is coated on a substrate and fixed on it, the top plate is suspended with a surface area \( A \). The top electrode is separated by a gap spacing \( d \) above the bottom one and fixed from one end. The other end is free to move. When a potential difference (V) is applied between electrodes, free end will tilt downwards (\( \delta \)) due to electrostatic force (Fig.1.)

![Fig. 1. Electrostatic actuator (Side View)](image-url)
When potential difference is removed, top electrode will come back to its initial (original) position due to restoring force of the bended structure. It is also sometimes called as spring force. If applied potential is increased beyond the some limit, top electrode will collapse onto the bottom electrode. While spring force term is proportional with the displacement, electrostatic force is proportional to square of the displacement. Hence, after some point, spring force cannot balance the electrostatic force any more. Then, top electrode collapses onto the bottom electrode. This point is named as pull-in limit.

Because cantilever is an electromechanical coupled system, its behavior is non-linear. Thus, having an analytical formula for pull-in limit is impossible. So, there is no simple formula to calculate it. People have been using lumped model (Hyun-Ho Yang et al., 2010; Seeger & Boser, 1999; Nielson & Barbastathis, 2006; Faris et al., 2006; Mol et al., 2007; Chowdhury et al., 2006; Owusu & Lewis, 2007) for decades. Lump model estimates the pull-in limit as one-third of the initial gap (d/3). However, experimental part of a study showed that pull-in limit is at a different value (Hu et al., 2004). Hu et al. utilized a linearized governing equation of a cantilever to demonstrate their analytical approach. They obtained the total energy expressions including the kinetic energy, strain energy, and electric potential energy. The total energy expression was substituted into Hamilton’s principle, and obtained partial differential equation with a nonlinear force term. This force term expanded by Taylor series about the equilibrium position and higher order terms neglected with an assumption of small displacement. At the end, structure-electrostatic coupling linear partial differential equation was obtained. Since small deflection was assumed and Taylor series expanded about equilibrium position, as the cantilever tip gets away from initial (original) position, error percentage also gets bigger (as high as 10%) when the tip is closer to pull-in limit(Hu et al., 2004). A later study has used Generalized Differential Quadrature Method which is accurate and efficient way to analyze a linear vector space by high-order polynomial approximation (Sadeghian et al., 2007). This approach gives smaller error in some measurements but not in all of them. Error gets as high as 5% when we close to pull-in limit.

When it is also checked by a software (ANSYS) which utilizes finite element method, pull-in limit seems to be at around 44% of initial gap which is consistent with experimental results (Hu et al., 2004; Sadeghian et al., 2007). Table 1 shows some simulation results for different initial gaps.

<table>
<thead>
<tr>
<th>Initial Gap(µm)</th>
<th>Pull-in Gap(µm)</th>
<th>Pull-in Gap/Initial Gap</th>
</tr>
</thead>
<tbody>
<tr>
<td>2</td>
<td>0.881</td>
<td>0.4405</td>
</tr>
<tr>
<td>5</td>
<td>2.203</td>
<td>0.4406</td>
</tr>
<tr>
<td>10</td>
<td>4.403</td>
<td>0.4403</td>
</tr>
</tbody>
</table>

Table 1. Ansys simulation Pull-in results of a cantilever with L = 200 µm.

These results show that the lumped model is not a very good approximation of the system. In fact, the cantilever beam system has two constrains: fixed end of the top electrode has zero displacement and zero angle even when voltage applied between electrodes. However, lumped model considers only second constrain for the sake of simplicity.
2. Lumped model

As it can be seen from Fig. 2, only zero angle constrain is considered and zero displacement is ignored. Nevertheless, the model is very simple. Therefore, calculations are easy and pull-in limit can be computed in few steps as one-third of the initial gap.

![Lumped model of a cantilever actuator.](image)

Stored energy in a parallel plate capacitor is

\[ U = \frac{1}{2} CV^2 \]  \hspace{1cm} (1)

Force due to this energy is

\[ F = \frac{dU}{dx} \]  \hspace{1cm} (2)

Therefore,

\[ F = \frac{d}{dx} \left( \frac{1}{2} CV^2 \right) = \frac{1}{2} \frac{dC}{dx} V^2 \]  \hspace{1cm} (3)

Value of a parallel plate capacitor is

\[ C = \frac{\varepsilon_0 A}{x} \]  \hspace{1cm} (4)

\( \varepsilon_0 \) is permittivity of free space, \( A \) is area of one of the parallel plates, and \( x \) is the distance between plates.
So,  
\[
\frac{dC}{dx} = -\frac{\varepsilon_0 A}{x^2}
\]  
(5)

Then, electrostatic force term is  
\[
F_e = -\frac{\varepsilon_0 AV^2}{2x^2} \quad \text{(- sign shows direction of the force)}
\]  
(6)

Electrostatic force term and spring force term will be equal to each other for equilibrium,  
\[
F_e = F_s
\]  
(7)

\[
\frac{\varepsilon_0 AV^2}{2x^2} = k\delta, \quad \delta = (d - x)
\]  
(8)

\[
2k\left(x^2d - x^3\right) = \varepsilon_0 AV^2
\]  
(9)

Potential can be get as  
\[
V = \sqrt{\frac{2k}{\varepsilon_0 A}\left(x^2d - x^3\right)}
\]  
(10)

Top electrode will collapse when  
\[
\frac{dV}{dx} = 0
\]  
(11)

So, if derivative is taken of Eq. (10) we have  
\[
2xd - 3x^2 = 0
\]  
(12)

Then critical x value can be get as  
\[
x_{\text{critical}} = \frac{2}{3}d
\]  
(13)

Displacement of top electrode at the limit condition can be found as  
\[
\delta_{\text{critical}} = \frac{1}{3}d
\]  
(14)

Thus, critical value of the potential difference can be calculated as  
\[
V_{\text{critical}} = \sqrt{\frac{2k}{\varepsilon_0 A}\left(\frac{2}{3}d\right)^2 \left(\frac{2}{3}d\right)^3}
\]  
(15)

Therefore, it can be simplified as
New Approach to Pull-In Limit and Position Control of Electrostatic Cantilever Within the Pull-In Limit

\[ V_{\text{critical}} = \sqrt[3]{\frac{8}{27}} \frac{k d^3}{\varepsilon_0 A} \]  \hspace{1cm} (16)

\( k \) can be obtained for a cantilever as (Saha et al., 2006)

\[ k = \frac{2}{3} E w \left( \frac{t}{L} \right)^3 \]  \hspace{1cm} (17)

and insert this in Eq. (16), and replace \( A \) with \( wL \). We can get

\[ V_{\text{critical}} = \sqrt[3]{\frac{16 E d^3 t^3}{81 \varepsilon_0 L^4}} \]  \hspace{1cm} (18)

3. Bisection model

Since model has two different sections, it is named as Bisection Model and can be seen in Fig. 3. Bisection model considers two constraints of fixed end of the top electrode. Fixed end has both zero displacement and zero angle while the other end is free to tilt linearly around pivot. Pivot point is placed 1/3 of the cantilever length from fixed end of top electrode. There is no specific reason for 1/3 ratio exactly. Since, the left side of the cantilever is fixed, there is very small movement at the left side. So, we model the structure in such a way that 1/3 of the cantilever is not moving at all and rest is moving linearly around the break point (pivot). By doing this, we still have very simple model as Lumped model and also consider both constraints of fixed end. Therefore, we can have a simple formula for the structure. Electrostatic force is placed at the free end of the top electrode since this end is close to bottom electrode and force gets its biggest value over there. Restoring force is placed at the one third of the movable part since it has to be close to pivot.

![Fig. 3. New Approach (Bisection Model) to cantilever actuator.](www.intechopen.com)
In this model, capacitance of the system has two parts (see Fig. 4.)

![Diagram of bisection model capacitor calculation]

Fig. 4. Bisection Model capacitor calculation.

C₁ and C₂ can be found as

\[ C_1 = \varepsilon_0 \frac{wL}{3d} \quad \text{and} \quad C_2 = 2\varepsilon_0 wL \ln\left( \frac{d}{d-\delta} \right) \]  \hspace{1cm} (19)

Where w and L are width and length of the cantilever respectively.

Therefore, total capacitance of the system is

\[ C_T = C_1 + C_2 = \frac{1}{3} \varepsilon_0 wL \left( \frac{1}{d} + 2 \ln\left( \frac{d}{d-\delta} \right) \right) \]  \hspace{1cm} (20)

And electrostatic force term can be obtained as

\[ F_e = \frac{1}{2} \left[ \frac{d}{d\delta} (C_1+C_2) \right] V^2 + \left( \frac{d}{d\delta} V^2 \right) (C_1+C_2) \]  \hspace{1cm} (21)

Since \( V \) (potential difference between electrodes) is constant between plates and C₁ is also constant, equation can be written shortly as

\[ F_e = \frac{1}{2} \frac{dC_2}{d\delta} V^2 \]  \hspace{1cm} (22)

Since

\[ \frac{dC_2}{d(d-\delta)} = \frac{2}{3} \left( \varepsilon_0 wL \ln\left( \frac{Ld}{Ld-L\delta} \right) - \frac{\varepsilon_0 wL^2}{\delta^2} + \frac{\varepsilon_0 wL^2}{\delta L(d-\delta)} \right) \]  \hspace{1cm} (23)
The electrostatic force term can be obtained as

$$F_e = \frac{1}{3} \varepsilon_0 w L \left( -\ln\left( \frac{d}{d-\delta} \right) d + \ln\left( \frac{d}{d-\delta} \right) d+\delta \right) \delta^2 (d-\delta) V^2$$ \hspace{1cm} (24)

The storing force term can be written as

$$F_s = k \frac{\delta}{3}$$ \hspace{1cm} (25)

and $k$ can be obtained for a cantilever as (Saha et al., 2006)

$$k = \frac{2}{3} E w \left( \frac{t}{L} \right)^3$$ \hspace{1cm} (26)

Where $E$ and $t$ are Young’s modulus and thickness of top electrode.

In the Bisection Model only $2L/3$ part of the upper electrode is free to move. So, by substituting $2L/3$ to $L$, $k$ can be calculated as

$$k = \frac{9}{4} E w \left( \frac{t}{L} \right)^3$$ \hspace{1cm} (27)

for Bisection Model. Since moments of the electrostatic and restoring forces are equal, we can write

$$\frac{6}{9} F_e = \frac{2}{9} F_s$$ \hspace{1cm} (28)

Therefore, the relation between applied voltage and displacement is given by

$$V = \left[ \frac{3 E t^3 \delta^3 (d-\delta)}{4 \varepsilon_0 L^4 (-\ln\left( \frac{d}{d-\delta} \right) d + \ln\left( \frac{d}{d-\delta} \right) d+\delta) \delta^2 (d-\delta) V^2} \right]^{1/2}$$ \hspace{1cm} (29)

This equation is valid not only for pull-in limit, but also for all values within the pull-in limit.

To find the pull-in limit, we have to take derivative of $V$ with respect to $\delta$. So;

$$\frac{dV}{d\delta} = \frac{-\sqrt{3} E t^3}{4} \left( 4\delta^2 - 3d\delta + \left( 3\delta^2 - 6\delta d + 3d^2 \right) \ln\left( \frac{d}{d-\delta} \right) \delta^2 (d-\delta) V^2 \right)^{1/2} = 0$$ \hspace{1cm} (30)
There is no analytical solution to this equation. Hence, computational result has been obtained as:

\[
\frac{\delta_{\text{max}}}{d} = 0.440423
\]  

(31)

In addition, when a graph of the equation is drawn, it shows stable and unstable regions (Fig. 5). It can be seen that the Pull-in Limit is at the 44% of the initial gap.

\[
V_{\text{critical}} = \sqrt{\frac{69}{50000} \frac{kd^5}{\varepsilon_0 A}}
\]  

(32)

and insert Eq. (27) into Eq. (32), and replace \( A \) with \( wL \). We can get

\[
V_{\text{critical}} = \sqrt{\frac{621}{2000} \frac{Ed^3t^3}{\varepsilon_0 L^4}}
\]  

(33)
Eq. (33) is very similar with Lumped Model’s Eq. (18) except coefficient which helps to get better results when compared with Lumped Model.

Table 2 and 3 show comparison of Ansys simulation results and values obtained from Bisection Model and percentage error for cantilever with different lengths.

<table>
<thead>
<tr>
<th>(Initial gap=2µm</th>
<th>$V_{\text{max}}$(V) From Bisection Model</th>
<th>$V_{\text{max}}$(V) From ANSYS</th>
<th>% Error</th>
</tr>
</thead>
<tbody>
<tr>
<td>L=150</td>
<td>27.4707</td>
<td>27.3408</td>
<td>0.475</td>
</tr>
<tr>
<td>L=200</td>
<td>15.4523</td>
<td>15.4179</td>
<td>0.223</td>
</tr>
<tr>
<td>L=250</td>
<td>9.8894</td>
<td>9.8985</td>
<td>0.092</td>
</tr>
<tr>
<td>L=300</td>
<td>6.8677</td>
<td>6.8284</td>
<td>0.575</td>
</tr>
<tr>
<td>L=400</td>
<td>3.8631</td>
<td>3.8604</td>
<td>0.069</td>
</tr>
<tr>
<td>L=500</td>
<td>2.4724</td>
<td>2.4715</td>
<td>0.036</td>
</tr>
</tbody>
</table>

Table 2. Comparison of $V_{\text{max}}$ (Pull-in Voltage) values for cantilevers with different lengths

<table>
<thead>
<tr>
<th>(L=150µm, d=2µm)</th>
<th>Voltage (V) From Bisection Model</th>
<th>Voltage (V) From ANSYS</th>
<th>% Error</th>
</tr>
</thead>
<tbody>
<tr>
<td>$\delta = 0.01415$ (0.71 %)</td>
<td>5.0549</td>
<td>5.0</td>
<td>1.098</td>
</tr>
<tr>
<td>$\delta = 0.05829$ (2.91 %)</td>
<td>10.1072</td>
<td>10.0</td>
<td>1.072</td>
</tr>
<tr>
<td>$\delta = 0.1386$ (6.93 %)</td>
<td>15.1544</td>
<td>15.0</td>
<td>1.030</td>
</tr>
<tr>
<td>$\delta = 0.2714$ (13.57 %)</td>
<td>20.1942</td>
<td>20.0</td>
<td>0.971</td>
</tr>
<tr>
<td>$\delta = 0.5165$ (25.83 %)</td>
<td>25.2056</td>
<td>25.0</td>
<td>0.822</td>
</tr>
<tr>
<td>$\delta = 0.6028$ (30.14 %)</td>
<td>26.1918</td>
<td>26.0</td>
<td>0.737</td>
</tr>
<tr>
<td>$\delta = 0.7419$ (37.10 %)</td>
<td>27.1588</td>
<td>27.0</td>
<td>0.588</td>
</tr>
<tr>
<td>$\delta = 0.7654$ (38.27 %)</td>
<td>27.2542</td>
<td>27.1</td>
<td>0.569</td>
</tr>
<tr>
<td>$\delta = 0.7963$ (39.82 %)</td>
<td>27.3518</td>
<td>27.2</td>
<td>0.558</td>
</tr>
<tr>
<td>$\delta = 0.8146$ (40.73 %)</td>
<td>27.3949</td>
<td>27.25</td>
<td>0.531</td>
</tr>
<tr>
<td>$\delta = 0.8808$ (44.04 %)</td>
<td>27.4628</td>
<td>27.34</td>
<td>0.449</td>
</tr>
</tbody>
</table>

Table 3. Comparison of Voltage values for arbitrary $\delta$ displacements.
Table 4 shows comparison of previous experimental, analytical results (Hu et al., 2004; Sadeghian et al., 2007), Bisection Model Result, and percentage error with respect to experimental results. Ansys simulation results also added for comparison.

<table>
<thead>
<tr>
<th>Voltage(V)</th>
<th>Experimental (Hu et al., 2004)</th>
<th>Analytical (Hu et al., 2004) / (Error)</th>
<th>Analytical (Sadeghian et al., 2007) / (Error)</th>
<th>Bisection Model / (%Error)</th>
<th>ANSYS</th>
</tr>
</thead>
<tbody>
<tr>
<td>20</td>
<td>90.5</td>
<td>90.2 / (0.3%)</td>
<td>90.2 / (0.3%)</td>
<td>90.4 / (0.1%)</td>
<td>90.4</td>
</tr>
<tr>
<td>40</td>
<td>84.6</td>
<td>84.3 / (0.4%)</td>
<td>84.1 / (0.6%)</td>
<td>85.1 / (0.6%)</td>
<td>85.1</td>
</tr>
<tr>
<td>60</td>
<td>70.0</td>
<td>71.5 / (2.1%)</td>
<td>69.1 / (1.2%)</td>
<td>73.2 / (4.5%)</td>
<td>73.2</td>
</tr>
<tr>
<td>65</td>
<td>64.0</td>
<td>67.2 / (5.0%)</td>
<td>59.6 / (6.9%)</td>
<td>67.4 / (5.3%)</td>
<td>67.6</td>
</tr>
<tr>
<td>67</td>
<td>59.0</td>
<td>65.0 / (10.2%)</td>
<td>-</td>
<td>64.1 / (8.7%)</td>
<td>64.5</td>
</tr>
</tbody>
</table>

Table 4. Comparison of displacements for different voltage values. Errors are respect to experimental results.

4. Conclusion

Values calculated from Bisection Model are very close to those obtained from ANSYS. Especially, when the displacement is larger than 10% of the initial gap, all the errors are within 1% (see Table 3). Therefore, Bisection Model not only gives a better pull-in limit when compared with previous lumped model, but also has simpler analytical result when compared with previous discrete models. At the same time, it gives satisfactory results for applied voltages for given displacements of top electrode’s free end. Bisection Model is also very successful when compared to experimental studies. Percentage error level of Bisection Model is comparable when displacement is small, and gets better when displacement is close to pull-in limit (see Table 4). Bisection Model also gives a simple formula to use instead of using numerical methods which is time consuming and requires computation capacity.

5. References


New Approach to Pull-In Limit and Position Control of Electrostatic Cantilever Within the Pull-In Limit


In this book, the authors provide state-of-the-art research studies on electrostatic principles or include the electrostatic phenomena as an important factor. The chapters cover diverse subjects, such as biotechnology, bioengineering, actuation of MEMS, measurement and nanoelectronics. Hopefully, the interested readers will benefit from the book in their studies. It is probable that the presented studies will lead the researchers to develop new ideas to conduct their research.

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